

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q78963

Hiroto SAKI, et al.

Appln. No.: 10/743,437

Group Art Unit: 1792

Confirmation No.: 8137

Examiner: James LIN

Filed: December 23, 2003

For: METHOD FOR PRODUCING LIGHT-TRANSMITTING ELECTROMAGNETIC  
WAVE-SHIELDING FILM, LIGHT-TRANSMITTING ELECTROMAGNETIC WAVE-  
SHIELDING FILM AND PLASMA DISPLAY PANEL USING THE SHIELDING FILM

STATEMENT UNDER 37 C.F.R. § 1.97(e)

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450  
Sir:

The undersigned hereby states, upon information and belief:

That each item of information contained in the Information Disclosure Statement filed concurrently herewith was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of said Information Disclosure Statement.

Respectfully submitted,



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WASHINGTON OFFICE

23373

CUSTOMER NUMBER

Date: April 6, 2009